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(71) Applicant (for all designated States except US): BEKAERT VDS [BE/BE]; E-3 Laan 75-79, B-9800 DEINZE (BE).

(72) Inventors; and

- (75) Inventors/Applicants (for US only): BLONDEEL, Anja [BE/BE]; Krekelstraat 119, B-9800 DEINZE (BE). DE BOSSCHER, Wilmert [BE/BE]; Noordhoutstraat 22, B-9031 DRONGEN (BE).
- (74) Agent: MESSELY, Marc; Bekaertstraat 2, B-8550 ZW-EVEGEM (BE).
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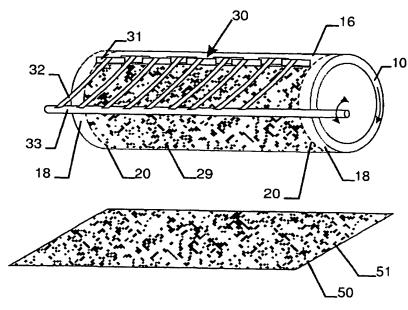
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to break the vacuum, so that the machine downtime is reduced.

(57) Abstract: A method for improving the sputter deposition process is provided. The method comprises the following steps: a) providing a vacuum; b) providing an electrode (10, 34, 34', 44, 44') in the provided vacuum; c) providing a substrate in said vacuum, said substrate having no contact with said electrodes (10,34,34,44,44) d) providing a device (22, 22', 24, 24', 26, 26', 28, 28', 30, 36, 36', 48, 48') in the vacuum. The device is in relative motion to the electrode and is in contact with the electrode over a contact zone. The device removes solid material from the electrode or applies solid material to the electrode. The method is carried out by means of a simple mechanism. There is no need for complicated electronics or sophisticated control algorithms. The method is carried out in vacuum, i.e. there is no need

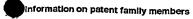
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A. CLASS IPC 7	SIFICATION OF SUBJECT MATTER C23C14/34 C23C14/56				
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Category °	Citation of document, with indication, where appropriate, of the	Relevant to claim No.			
A	US 2002/127861 A1 (CHEN TA-BIN 12 September 2002 (2002-09-12) paragraphs '0025! - '0029!; clai			1–17	
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Further documents are listed in the continuation of box C. Patent family members are listed				annex.	
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